

Vector Zernike WFS Progress at JPL: Liquid Crystal and Metasurface Devices and Applications

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Development of Vector Zernike WFS

- ZWFS Operational Principle
- Origin and development
- Applications
- ZWFS Limitations and next generation devices
- Vector Zernike with Liquid Crystal Devices
- Vector Zernike with Metasurface Devices
 - Metasurface Devices and Status
- Impact of ZWFS
- The Future



Operational Principle

- 1. Put a phase-dimple in an intermediate focal plane
- 2. Look at the subsequent pupil plane

$$E_2(\mathbf{x}_2) = L[E(\mathbf{x}_1)]e^{i\theta_0} + (E(\mathbf{x}_1) - L[E(\mathbf{x}_1)])$$

 $I_{2}(\boldsymbol{x}_{2}) = A_{0}^{2} (P^{2}(\boldsymbol{x}_{2}) + 2b^{2}(\boldsymbol{x}_{2}) + 2b(\boldsymbol{x}_{2})P(\boldsymbol{x}_{2})(\sin(\phi(\boldsymbol{x}_{2}) - \beta(\boldsymbol{x}_{2}))) - \cos(\phi(\boldsymbol{x}_{2}) - \beta(\boldsymbol{x}_{2})))$

$$L[E_1(\boldsymbol{x}_1)] = \mathcal{F}\left[\mathcal{F}\left(E_1(\boldsymbol{x}_1)\right) \cdot M\left(\frac{\rho}{a}\right)\right] = A_0 b(\boldsymbol{x}_2) e^{i\beta(\boldsymbol{x}_2)}$$

 $E(u,v) = P(u,v) \cdot A(1 + \varepsilon(u,v))e^{i\phi(u,v)}$ Phase Mask Dia = $-\lambda/D$ Re-imaged Pupil
Electric Field $U^{-}(\xi) = \mathcal{F}(E_{1}(\mathbf{x}_{1})) \cdot M\left(\frac{\rho}{a}\right)e^{i\theta_{0}} + \mathcal{F}(E_{1}(\mathbf{x}_{1})) \cdot \left(1 - M\left(\frac{\rho}{a}\right)\right)$ $Pase Mask Dia = -\lambda/D$ Re-imaged Pupil
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Steeves, J. *et al.*, "Picometer Wavefront Sensing via the Phase-Contrast Technique", in prep.

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Origin and Development





FIG. 10.—Value of β_p as a function of angular separation for the WFSs compared in this study. The WFSs were optimized for a separation of 0."5. For the SHWFS, $r_0 = 0.2$ m and $\lambda_0 = 0.5 \ \mu$ m.

Zernike, F. Diffraction theory of the knife-edge test and its improved form the phase contrast method. *Mon. Notices Royal Astron. Soc.* 94, 377– 384 (1934)

© 2020 California Institute of Technology. Government sponsorship acknowledged. Guyon, O, "Limits of Adaptive Optics for High-Contrast Imaging", Ap. J, pp. 592 – 614 (2005).

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N'Diaye, M. *et al.* Calibration of quasi-static aberrations in exoplanet direct-imaging instruments with a Zernike phase-mask sensor. II. Concept validation with ZELDA on VLT/SPHERE. *Astron. Astrophys.* 592, A79, DOI: 10.1051/0004-6361/ 201628624 (2016).



Applications









WFIRST-CGI Low-Order WFS

Shi, F. *et al.* Low-order wavefront sensing and control for WFIRST-AFTA coronagraph. *J. Astron. Telesc. Instrum. Syst.* 2, 1–19, (2016); DOI: 10.1117/1.JATIS.2.1.011021.

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Phasing Segmented Apertures

Wallace, J.K, "Common-path interferometric wavefront sensing for space telescopes", IEEE Aerospace Conference (2011) DOI: 10.1109/AERO.2011.5747418.

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Keck Planet Imager and Characterizer (KPIC)

Mawet, *et al.*, "Keck Planet Imager and Characterizer: status update", Proc. SPIE 10703, Adaptive Optics Systems VI, 1070306 (10 July 2018); doi: <u>10.1117/12.2314037</u>



Limitations and Next Generation Devices

- A single-dimple is limited in sensing by the phase-dimple depth (or height)
- It's possible to increase the dynamic range by having a series of dimples of different depth, and scanning the white light fringe.
- However, a device with +/- $\pi/2$ diversity helps.

Jackson, Kate, et al. "Co-phasing primary mirror segments of an optical space telescope using a long stroke Zernike WFS", Proc. SPIE 9904 (2016);

doi: 10.1117/12.2231736















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Limitations and Next Generation Devices

- Single Dimple has limited dynamic range.
- When the phase error gets too large, the brightness drops.
- Thus brightness can be associated with more than one phase error.
- Extra diversity can resolve this.

3.0 2.5 Pupil Intensity (arb.) 2.0 1.5 1.0 0.5 0.0 0 2 -1 3

Phase error (radians)

Non–linear response of ZWFS Intensity



Vector Zernike with Liquid Crystal Devices



Doelman, D., *et al.*, "Simultaneous phase and amplitude aberration sensing with a liquid-crystal vector-Zernike phase mask", Optics Letters, **44** (1) pp. 17-20 (2019). <u>https://doi.org/10.1364/OL.44.000017</u>



Liquid Crystal vZWFS testing at JPL

Segmented **Deformable Mirror**

Vector Zernike Focal plane mask (liquid crystal)



20° Wollaston Pupil Imaging Pupil Prism Lens



CMOS Camera





Vector Zernike with Metasurface Optics



Device operation requires phase shift over a Ø 23.8 µm domain with $\varphi_x = \pi/2$ for x-polarized and $\varphi_y = 3\pi/2$ for y-polarized light with respect to the unpatterned substrate



Metasurface Optics



Arbabi, Amir, *et al.*, "Dielectric metasurfaces for the complete control of phase and polarization with subwavelength spatial resolution and high transmission", Nature Nanotechnology, Vol. 10, pp. 937 – 944 (2015); DOI: 10.1038/NNANO.2015.186

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Finite Difference Time Domain Simulations



Software tool *Lumerical* to solve Maxwell's equations of light propagation



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Application to KPIC





Mechanical Design



Impact of the ZWFS

- ZWFS has demonstrated itself to be a simple and robust method of measuring very small phase errors in optical systems.
 - It's application to high-contrast imaging is a great match of both implementation and capability to need.
- Development of new devices will enhance its capabilities in both extending the dynamic range and increasing sensitivity.



The Future

- It's time to take a different perspective, one that is more systems level.
- If we use a ZWFS to continuously monitor the wavefront in a highcontrast system, how might we use this capability to reduce requirements on the overall system?
- In particular, consider relaxing stringent requirements on DM's and optical alignment.
- The Zernike WFS may not simply aide in establishing and maintaining high contrast, it may be *essential* for architecting these systems by enabling a new trade space.



Thank you for your time and attention.

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